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Combinatorial Investigation of Fe-Si-Zn Thin Film Negative Electrodes for Li-Ion Batteries,
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27 capacity of 2190 Ah/L. Pure Si negative electrodes have been studied in detail,¹⁻⁶ but due to
28 their high volume expansion at full lithiation (~280%) their cycleability is poor when cycled to
29 full capacity. It has been shown that the cycleability of pure crystalline Si electrodes can be
30 significantly improved by cycling to a limited capacity and keeping the lower cutoff voltage
31 above 170 mV.⁵ Cycling of Si can also be improved by adding elements that suppress formation
32 of $\text{Li}_{15}\text{Si}_4$, such as Zn, Ag, and Sn, or by reducing volume expansion by adding an inactive
33 phase, such as Fe.⁷⁻¹⁰ Numerous Si-containing alloy negative electrode materials have been
34 studied, including, but not limited to; Si-Sn,⁹ Si-C,¹¹ Si-Fe,^{10,12} Si-TiN-C,¹¹ Si-Zn-C,¹³ Si-Al-
35 Sn,¹⁴ Si-Al-Mn,¹⁵ and Si-Sn-C.¹⁶

36 Improvement in cell performance can be obtained by incorporating elements that do not
37 alloy with Li into alloy electrodes. Adding an inactive phase to the electrode dilutes the volume
38 expansion, improves cycle life, and increases energy density at a given volume expansion due to
39 lower average voltage compared to pure Si cycled to limited capacity.¹⁷ Fleischauer *et al.*
40 showed that increasing Mn concentration in Si-Al-Mn thin-film electrodes improved capacity
41 retention, but total specific capacity decreased with increasing Mn.¹⁵ Dong *et al.* found that
42 $\text{Fe}_{0.25}\text{Si}_{0.75}$ electrodes exhibited reduced initial capacity, but better cycleability and higher
43 coulombic efficiency (CE) compared to pure Si electrodes.¹²

44 Elements that are active with Li, but with lower specific capacity (and lower volume
45 expansion) than Si have also been shown to improve cycling performance of alloy negative
46 electrodes. These elements suppress formation of $\text{Li}_{15}\text{Si}_4$ formation, avoiding two-phase regions
47 and high internal stresses during cycling. Zn, Ag, and Sn have all been found to improve cycling
48 for this reason.¹⁸ Zn alloys with Li in a 1:1 ratio and has a theoretical capacity of 410 mAh/g.
49 Hatchard *et al.* found that Si-Zn thin film electrodes with approximate composition of $\text{Si}_{0.4}\text{Zn}_{0.6}$

50 had reversible capacities over 1000 mAh/g and cycled quite well.⁷ In-situ X-Ray Diffraction
51 (XRD) experiments were used to show that Si-Zn electrodes become amorphous during cycling.
52 Electrodes with greater than 20% content suppressed the formation of $\text{Li}_{15}\text{Si}_4$ during cycling.
53 Yoon *et al.* reported good cycling performance for mechanically milled Si-Zn-C composite
54 electrodes.¹³ They found that 91% of the initial discharge capacity could be retained for 40
55 cycles.

56 The binary systems of Si-Fe, Si-Zn, and Fe-Zn have been previously tested as negative
57 electrode materials for Li-ion batteries.^{7,10,19} Increasing concentration of Fe and Zn in Fe-Si and
58 Si-Zn alloys, respectively, has been reported to improve cycling performance in Li-ion battery
59 negative electrodes.^{7,10,12,19} Fleischauer *et al.* studied the electrochemistry of $\text{Si}_x\text{Fe}_{1-x}$ thin films
60 and found that capacity decreased nearly linearly from pure Si to 60 atom % Si.¹⁰ They found
61 that capacity can be predicted nicely when $\text{Si}_x\text{Fe}_{1-x}$ is assumed to comprise $(2x - 1)$ Si and $(2 -$
62 $2x)$ inactive Si-Fe for $0.5 < x < 1$. The addition of Fe has also been reported to improve cycling
63 performance in Fe-Zn alloy negative electrodes.²⁰ Sputtered $\text{Fe}_x\text{Zn}_{1-x}$ libraries have recently
64 been studied in detail by MacEachern *et al.*¹⁹ The capacity of $\text{Fe}_x\text{Zn}_{1-x}$ electrodes was found to
65 decrease linearly with increasing Fe content up to $x = 0.12$ where capacity dropped sharply to
66 zero. Capacities for $x < 0.12$ can be predicted well assuming each additional Fe atom renders
67 two Zn atoms inactive. Ex-situ Mössbauer studies of cycled $\text{Fe}_{0.08}\text{Zn}_{0.92}$ electrodes suggested
68 that during lithiation Fe was displaced from the alloy, resulting in formation of LiZn, inactive δ -
69 phase Fe-Zn, and isolated Fe. Coulombic efficiencies and capacity retention were improved with
70 increasing Fe concentration, although no compositions showed good overall performance.¹⁹

71 Here, the structure and electrochemistry of the Fe-Si-Zn thin-film system is studied. This
72 system is predicted to comprise three phases: an inactive FeSi phase, an active pure Si phase and

73 an active pure Zn phase, based on the ternary phase diagram and previous electrochemical
74 measurements done on the Fe-Si binary system.^{21,22} In studying this system it was hoped that the
75 advantages of the Si-Fe system (lower volume expansion) and the Si-Zn system (suppression of
76 $\text{Li}_{15}\text{Si}_4$ formation) could be combined to result in high performance anode materials.

77

78 **Experimental**

79 Thin film libraries were produced using a Corona Vacuum Coated model V3-T sputtering
80 system. A base pressure of $< 4 \times 10^{-7}$ Torr was obtained by evacuating the vacuum chamber using
81 a Varian 500 L/s turbo pump backed by a roughing pump. Ar gas was used to maintain the
82 pressure at 1 mTorr during sputter deposition. Three types of 5.08 cm diameter targets were
83 used on four of the five available magnetrons: one Zn target (99.99% purity, Kurt J. Lester
84 Company), two Si targets (99.99% purity, Williams Advanced Materials), and one Fe target
85 (produced by stacking two 50 mm diameter disks cut from 0.7 mm thick sheets of grade 1008
86 low carbon steel). A chrome plasma scrubber electrode was mounted on the fifth magnetron.

87 Library composition was made to vary in a linear and orthogonal manner by using
88 different stationary masks over the targets. Constant masks were used for the Si targets, and
89 linear out masks were used for the Fe and Zn targets. The sputtering table was rotated at 15 rpm
90 to ensure sufficient atomic level mixing during sputtering. In this way, four libraries were
91 sputtered to obtain a range of compositions and to test for reproducibility. The libraries had
92 constant Si content, while the Fe and Zn content varied orthogonally over the library. The details
93 of the combinatorial sputtering system have been described by Dahn *et al.*²³ and the techniques
94 used to obtain ternary libraries have been presented by Fleischauer *et al.*²⁴ Various substrates
95 were placed on the sputtering table for characterization of the deposited thin film libraries. A $5 \times$

96 5 grid of copper foil disks were used to determine the mass of the deposited film and were also
97 used as electrodes in electrochemical coin cells. A silicon (100) wafer was used for X-ray
98 diffraction measurements and a copper coated glass plate was used for electron microprobe
99 composition analysis of the libraries.

100 The position dependence of the mass was found by weighing the Cu disks on a Sartorius
101 SE-2 microbalance (0.1 μg precision) before and after sputter deposition. The films had mass
102 loadings of 0.25 - 1.56 mg/cm^2 and calculated thickness between 0.80 - 5.71 μm , depending on
103 the library. Mass loading and calculated thickness for individual libraries is given in Table 1.
104 Compositions as a function of position within the libraries was determined with a JEOL-8200
105 Superprobe electron microprobe using wavelength dispersive spectroscopy on an 8×8 grid of
106 points over the sputtered library. X-ray diffraction (XRD) measurements were also obtained on
107 an 8×8 grid of points over the sputtered library using a Bruker D8 Discover X-ray
108 diffractometer equipped with a Cu target and a Cu-K_α monochromator. The X-ray beam was
109 incident on the sample at an angle of 6° , which does not satisfy the Bragg condition for Si; as a
110 result, the Si wafer acts as a zero background holder.

111 Electrodes deposited on Cu disks 1.26 cm^2 in area were incorporated into 2325 coin cells
112 with Li metal counter electrodes and 1 M LiPF_6 in ethylene carbonate (EC) / ethyl methyl
113 carbonate (EMC) / fluoroethylene carbonate (FEC) in a 2/7/1 v/v/v ratio for library Spt101 and 1
114 M LiPF_6 in EC/DEC/FEC 3:6:1 v/v/v electrolyte for library Spt107 (all from BASF, < 50 ppm
115 H_2O). The electrodes were separated with two layers of Celgard 2301 separator. All cell
116 assembly was performed in an Ar-filled glove box. Cells were cycled at 30°C with a Maccor
117 Series 4000 Automated Test System from 0.005 V to 1.2 V at a C/10 rate and trickled until a
118 C/20 rate was reached at the lower voltage limit during discharge (lithiation). The C rate was

119 calculated assuming that three phases are present in the sputtered film: FeSi, Si, and Zn and that
120 the FeSi phase is inactive, the remaining Si alloys with 3.75 Li per Si, and all the Zn present is
121 active and alloys with 1 Li per Zn.

122

123 **Results and Discussion**

124 Table 1 gives a summary of powers supplied to targets during sputtering and composition
125 ranges obtained for each run. All libraries were sputtered for 4 hours. Figure 1 shows the range
126 of Fe-Si-Zn compositions fabricated in a single sputtering run (Spt107). The labeled points
127 correspond to plots in Figure 2 which shows the X-Ray diffraction (XRD) patterns for library
128 Spt107. Figure 3 shows XRD patterns for the bottom row of Figure 2. The Zn concentration is
129 approximately constant along this row (~29 at%) and the Fe concentration increases from 4 at%
130 to 21 at%, while the Si concentration decreases from 67 to 50 at%.

131 It is clear from Figures 2 and 3 that the Zn microstructure in the film is dependent not
132 only on Zn concentration, but also on the Fe and Si concentration. Si-Zn thin films can be
133 sputtered amorphously for compositions with less than 45 at% Zn,⁷ which agrees well with the
134 results found in this work for the lowest Fe concentrations. Si-Fe thin films can be sputtered
135 amorphously for compositions with less than 72 at% Fe.²⁵ The range of compositions fabricated
136 in this work did not extend above 50 at% Fe and all compositions along the Si-Fe portion of the
137 phase diagram were found to be amorphous, agreeing with previously reported results.²⁵ Along
138 lines of constant Zn composition, crystalline Zn formation becomes more favorable when both
139 Fe and Si are present. Crystalline Zn peaks begin to appear in the XRD patterns when the Zn
140 concentration is above 25 at% in compositions with a 4:1 Si:Fe ratio. Figure 4 shows a summary
141 of the structures determined by XRD for all Fe-Si-Zn libraries presented in this work. The entire

142 shaded region in the figure indicates the total range of compositions while the darker shaded
143 region corresponds to the range of Fe-Si-Zn compositions that can be sputtered amorphously.

144 Figure 5 shows compositions on the Fe-Si-Zn Gibbs' Triangle for which electrochemical
145 studies are presented. The electrochemical results presented are for coin cells with electrodes
146 from library Spt101. Electrochemical measurements were also conducted using coin cells with
147 electrodes from library Spt107 and the results were consistent with those obtained from library
148 Spt101. Figure 6 correlates the electrodes used in coin cells prepared from library Spt101 with
149 the XRD patterns obtained from library Spt101.

150 Voltage curves for the first 1.5 cycles for Spt101 are shown in Figure 7. Voltage curves
151 for all compositions show long sloping plateaus, characteristic of amorphous materials. Two
152 distinct plateaus can be seen for voltage curves in the Si rich region (see plot 5 in Figure 7),
153 characteristic of amorphous Si.¹ As Zn and Fe concentrations in the electrode increase, these
154 plateaus become less defined. This can be seen more clearly in the differential capacity plots for
155 cells from library Spt101, shown in Figure 8. All plots show broad peaks during charge for the
156 first two cycles, indicating that the films remain amorphous during the first two cycles. The
157 peaks become less defined as Fe and Zn concentrations in the film increase. All electrodes
158 remain amorphous on cycling except those shown in panels 4 and 5 (electrodes with the highest
159 Si concentration), which show a sharp peak during charge for cycles 6-7 which is consistent with
160 the formation of $\text{Li}_{15}\text{Si}_4$.³ Hatchard *et al.* concluded that a sufficient amount of Zn in Si-Zn thin
161 film electrodes suppressed the formation of the $\text{Li}_{15}\text{Si}_4$ phase.⁷ In the present work, both Fe and
162 Zn appear to suppress $\text{Li}_{15}\text{Si}_4$ formation. The Zn and Fe concentrations required to suppress
163 $\text{Li}_{15}\text{Si}_4$ formation are 13 at% and 15 at%, respectively. Only electrodes containing the lowest Zn
164 and Fe concentrations showed evidence of $\text{Li}_{15}\text{Si}_4$ formation during cycling.

165 During the lithiation of Si-Zn thin films a ternary $\text{Li}_{2+x}\text{SiZn}$ phase is formed. During
166 delithiation, Zn does not phase separate and the films become amorphous or nanocrystalline.
167 This mechanism was thought to suppress Si phase aggregation during cycling and, as a result,
168 also suppress $\text{Li}_{15}\text{Si}_4$ formation.⁷ It is possible that the FeSi inactive phase may also suppress Si
169 aggregation in Si-Fe alloys, resulting in the suppression of $\text{Li}_{15}\text{Si}_4$ formation. However,
170 additional mechanisms may be operating that suppress $\text{Li}_{15}\text{Si}_4$ in these films, as will be discuss
171 below.

172 Average discharge and charge voltages for all compositions are between 0.11 V - 0.17 V
173 and 0.37 V - 0.42 V, respectively. Average charge and discharge voltages were calculated for
174 the first charge and second discharge. The average discharge voltage decreases with increasing
175 Fe concentration and the average charge voltage increases with increasing Zn concentration.
176 Thus, hysteresis in the voltage curves increases as Fe and Zn concentrations are increased
177 concurrently in the electrode. This is illustrated in Figure 9 which shows an overlay of three
178 normalized voltage curves for the most Si rich ($\text{Si}_{0.86}\text{Zn}_{0.08}\text{Fe}_{0.06}$), Zn rich ($\text{Si}_{0.66}\text{Zn}_{0.29}\text{Fe}_{0.05}$), and
179 Fe rich ($\text{Si}_{0.74}\text{Zn}_{0.06}\text{Fe}_{0.20}$) compositions in library Spt101. For the most Fe rich composition the
180 charge portion of the voltage curve is identical to the most Si rich composition, and the discharge
181 portion of the curve is at a lower voltage. Although Fe depresses the voltage of the discharge
182 voltage curve, the features in the discharge voltage curve remain unchanged. For the most Zn
183 rich composition the discharge portion of the voltage curve is identical to the most Si rich
184 composition, and the charge portion of the curve is at a higher voltage.

185 Variation in average voltage can also be seen in the differential capacity plots shown in
186 Figure 8. Fe concentration is increasing from right (panel 5) to left (panel 1) along the top row
187 of Figure 8. Positions of the discharge peaks near 0.09 V and 0.26 V shift to lower voltage as Fe

188 concentration is increased, decreasing the average discharge voltage. Zn concentration is
189 increasing from top (panel 5) to bottom (panel 25) in the rightmost column of Figure 8. As Zn
190 concentration is increased a broad peak on charge is introduced at 0.74 V, increasing the average
191 charge voltage. This high voltage peak has been previously observed in Si-Zn thin films.
192 Contour plots of average discharge (a) and average charge voltage (b) versus composition are
193 overlaid on a portion of the Fe-Si-Zn Gibbs' triangle in Figure 10. Surprisingly, the average
194 discharge voltage is a function of Fe content only (increasing Fe concentration decreases the
195 discharge voltage) and the average charge voltage is a function of Zn content only (increasing Zn
196 concentration increases the charge voltage).

197 The effect of the depression of the discharge voltage curve with increasing Fe content has
198 not been previously reported, although it can be readily seen in the differential capacity plots
199 shown in the study of all of the sputtered Si-M alloy systems (M = Fe, Mn, (Ni + Cr)) by
200 Fleischauer et al.¹⁰ We do not know the origin of this discharge voltage depression. Whatever
201 its cause, the depression in the voltage curve is as much as 0.75 V. Since $\text{Li}_{15}\text{Si}_4$ formation
202 occurs below 50 mV in pure Si,² the voltage depression caused by the addition of transition
203 metals is likely the cause of the suppression of $\text{Li}_{15}\text{Si}_4$ formation in Si-M alloys.

204 The initial coulombic efficiency (ICE) of the Fe-Si-Zn alloys varied from 0.80 (cell 10)
205 to 0.94 (cell 24). The ICE showed a linear dependence on Si concentration in the electrode. ICE
206 versus Si concentration is shown in Figure 11 for coin cells prepared from libraries Spt101 and
207 Spt107. A line of best fit determined by least squares is shown. Anomalous points were not
208 included in the fit. A contour plot of predicted and observed first charge capacities for cells from
209 library Spt101 is shown in Figure 12. Capacities of cells are predicted assuming all Fe is in an
210 inactive FeSi 1:1 phase, the remaining Si alloys with 3.75 Li per Si, and all Zn present is active

211 and alloys with 1 Li per Zn. Predicted capacities agree well with the observed capacities,
212 indicating that the thin-films comprise inactive FeSi, active Si, and active Zn.

213

214 **Conclusions**

215 Thin film libraries of Fe-Si-Zn were fabricated and characterized using combinatorial
216 high throughput techniques. A large range of Fe-Si-Zn compositions can be sputtered
217 amorphously near the Si-rich corner of the phase diagram. The voltage curves and capacities of
218 the films was strongly dependent on composition. Fe and Zn additions to Si were both found to
219 decrease capacity, but both also suppressed $\text{Li}_{15}\text{Si}_4$ formation during cycling. The mechanism by
220 which Zn suppresses Si formation has been previously studied. Here it was found that Fe
221 additions to Si causes a significant depression in the discharge voltage curve without changing its
222 shape. This depression in the voltage curve likely contributes to the suppression of $\text{Li}_{15}\text{Si}_4$
223 formation during cycling in Si-M active/inactive alloys in general.

224 Initial coulombic efficiencies up to 0.94 were observed. Initial coulombic efficiency and
225 hysteresis improved with increasing Si concentration in the electrodes. Capacities were
226 predicted assuming that only three phases were present in the electrodes: FeSi, Si, and Zn.
227 Observed capacities agreed well with predicted capacities for all compositions..

228 This work shows that a wide composition range of amorphous Fe-Si-Zn thin-film
229 materials can be fabricated and compositions with sufficient Fe and Zn content remain
230 amorphous on electrochemical cycling. Further work needs to be done to understand the
231 electrochemistry of Fe-Si-Zn materials, especially the effect of discharge voltage depression
232 caused by the addition of Fe. Preparation of these materials using bulk methods is underway to
233 determine electrochemical properties in conventional electrode coatings.

234

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237 of the Industrial Research Chair and Discovery Grant programs. We also acknowledge the
238 support of the Canada Foundation for Innovation, the Atlantic Innovation Fund and other
239 partners that fund the Facilities for Materials Characterization managed by the Institute for
240 Research in Materials.

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301

302

303 **Table 1**

304

Run ID	Power Supplied to Targets			Film Composition		Mass Loading (mg/cm ²)	Calculated Thickness (μm)	Electrochemistry Y/N
	Si (W)	Fe (W)	Zn (W)	Fe (at%)	Zn (at%)			
Spt074	130 (×2)	110	25	0.04 < x < 0.46	0.03 < y < 0.56	0.68 - 1.56	1.99 - 5.71	N
Spt094	130 (×2)	85	17	0.08 < x < 0.56	0.02 < y < 0.38	0.38 - 0.87	1.02 - 2.39	N
Spt101	130 (×2)	33	13	0.02 < x < 0.24	0.02 < y < 0.34	0.31 - 0.58	0.95 - 1.80	Y
Spt107	125 (×2)	32	13	0.02 < x < 0.23	0.02 < y < 0.31	0.25 - 0.46	0.80 - 1.50	Y

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306

307 Table 1 Summary of sputtered libraries presented in this work.

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322 **Figure Captions**

323 **Figure 1:** The Fe-Si-Zn ternary system as predicted by the Materials Project at 0 K.^{26,27} The
324 composition range of one sputtered library (Spt107) is superimposed on the diagram. Numbers
325 correspond to XRD patterns shown in Figure 2.

326

327 **Figure 2:** XRD patterns of library Spt107. Positions of Zn peaks are indicated with triangles
328 (Δ). Numbers in top right corner of each plot correspond to compositions shown in Figure 1.

329

330 **Figure 3:** XRD patterns of compositions with constant Zn and varying Fe concentration from
331 Figure 2 (approximately corresponding to compositions in the range of $\text{Fe}_y\text{Si}_{1-y-0.29}\text{Zn}_{0.29}$; $0 < y <$
332 0.2). Zn peaks are indicated with triangles (Δ). The arrow points in the direction of increasing
333 Fe concentration.

334

335 **Figure 4:** Range of compositions sputtered in this work superimposed on the Fe-Si-Zn ternary
336 system as predicted by the Materials Project at 0 K.^{26,27} The entire shaded region represents
337 compositions fabricated in all four libraries. The dark shaded region represents those
338 compositions which can be sputtered amorphously.

339

340 **Figure 5:** Compositions of coin cells prepared from library Spt101 superimposed on the Fe-Si-
341 Zn ternary system as predicted by the Materials Project at 0 K.^{26,27} Numbers correspond to plots
342 in Figures 6, 7, 10, and 12.

343

344 **Figure 6:** Position of coin cells from library Spt101 overlaid onto XRD patterns obtained from
345 library Spt101. Zn peaks are indicated with triangles (Δ).

346

347 **Figure 7:** Voltage versus capacity curves for cells from library Spt101. Numbers in the top right
348 corner correspond to numbers shown on coin cells in Figure 6.

349

350 **Figure 8:** Differential capacity curves for cells prepared from library Spt101. The first two
351 cycles are shown in black and the sixth and seventh cycles are shown in red.

352

353 **Figure 9:** Overlay of voltage curves from panels 1, 5, and 25 in Figure 7. Capacity is
354 normalized by first discharge capacity.

355

356 **Figure 10:** Contour plot of average discharge voltage (a) and average charge voltage (b) of the
357 second cycle for cells in Figure 7. Average voltage values in volts are indicated on contour lines.
358 Cell compositions are shown in grey.

359

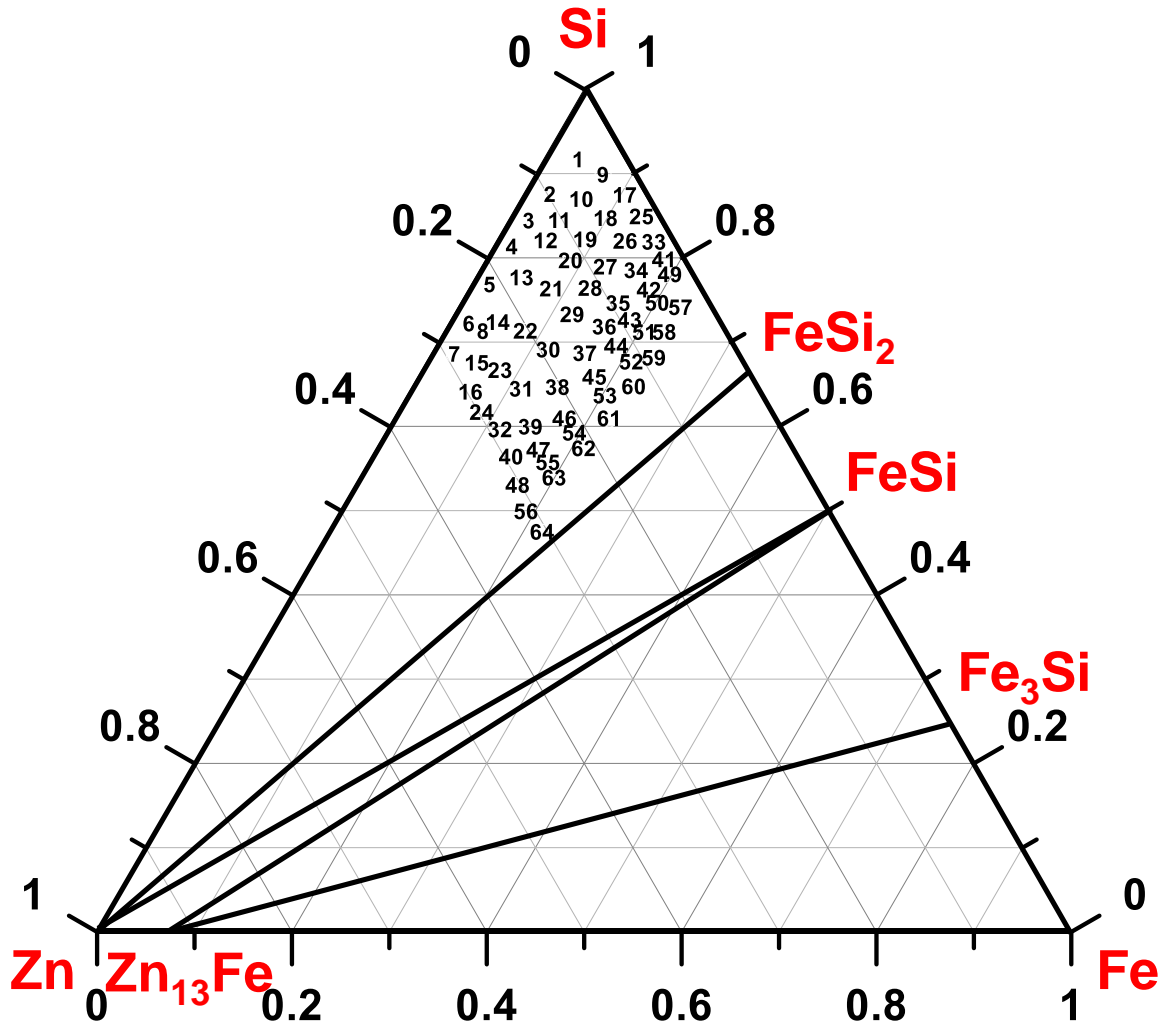
360 **Figure 11:** Initial coulombic efficiency as a function of Si concentration in the electrode for cells
361 prepared from libraries Spt101 (closed diamonds) and Spt107 (open diamonds). A line of best fit
362 by least squares is shown.

363

364 **Figure 12:** Contour plot of predicted (solid black lines) and observed (dashed red lines) capacity
365 for cells prepared from library Spt101 overlaid on a portion of the Fe-Si-Zn Gibbs' triangle.
366 Capacity values in mAh/g are indicated on contour lines. Cell compositions are shown in grey.

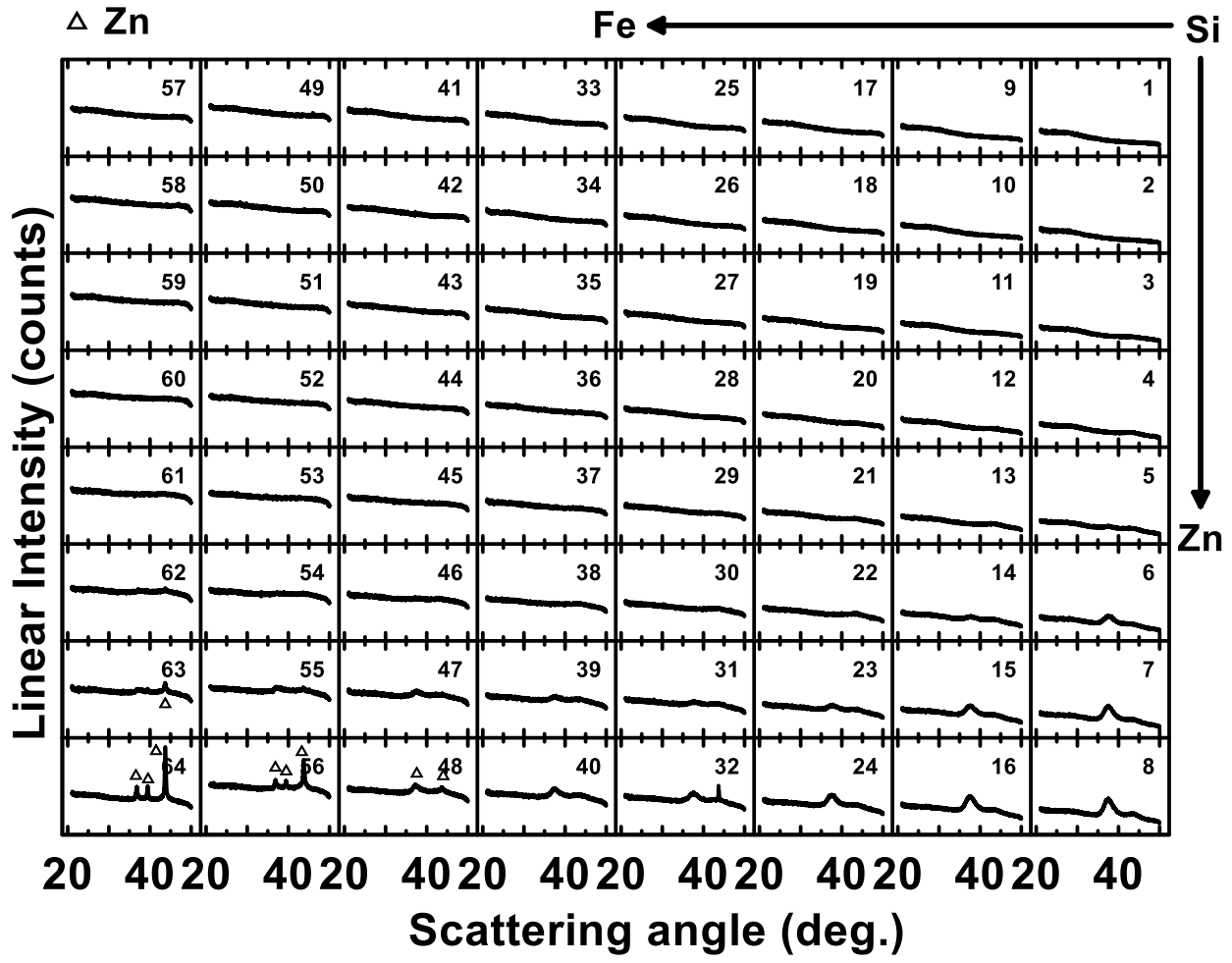
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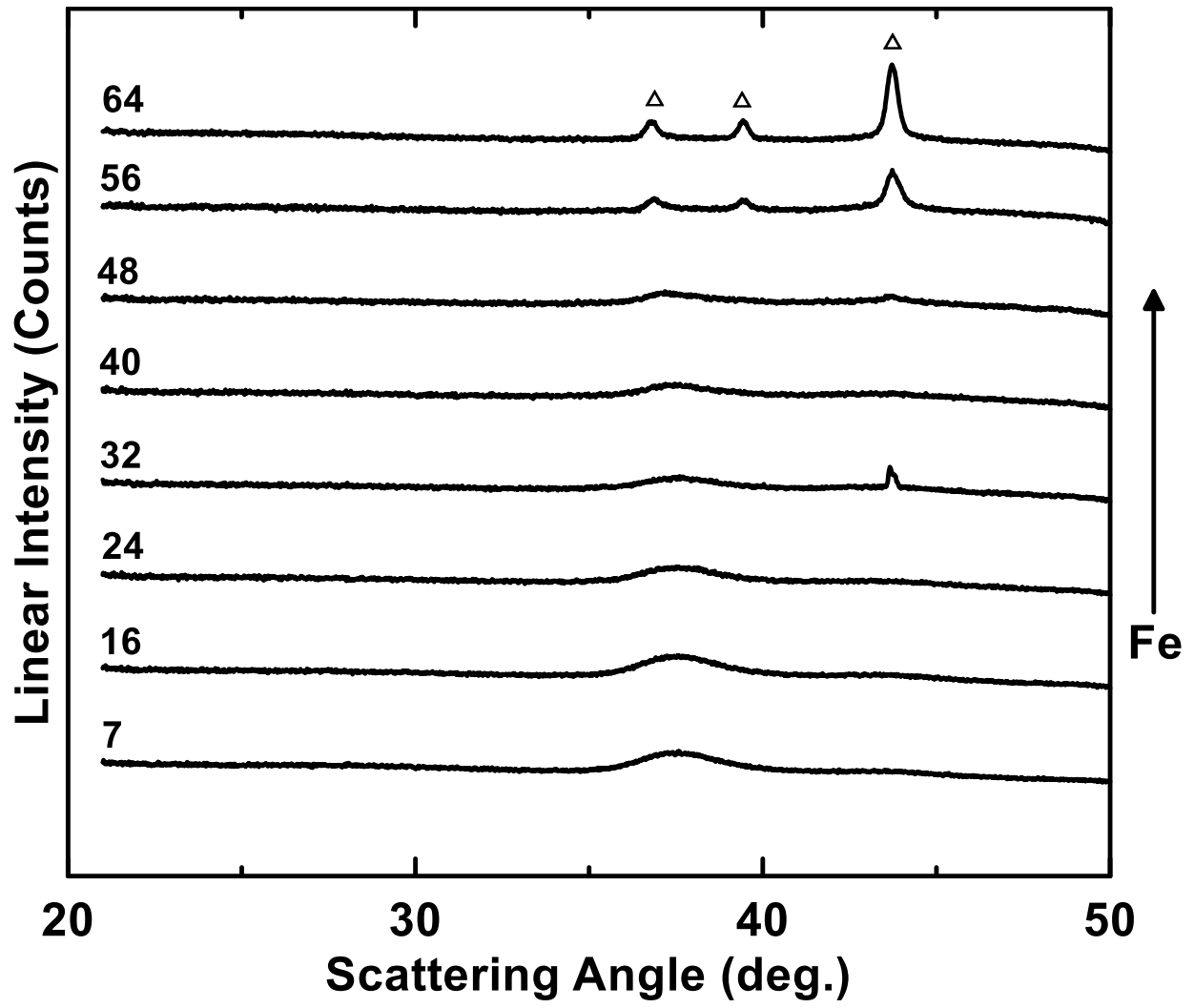
376 Figure 2
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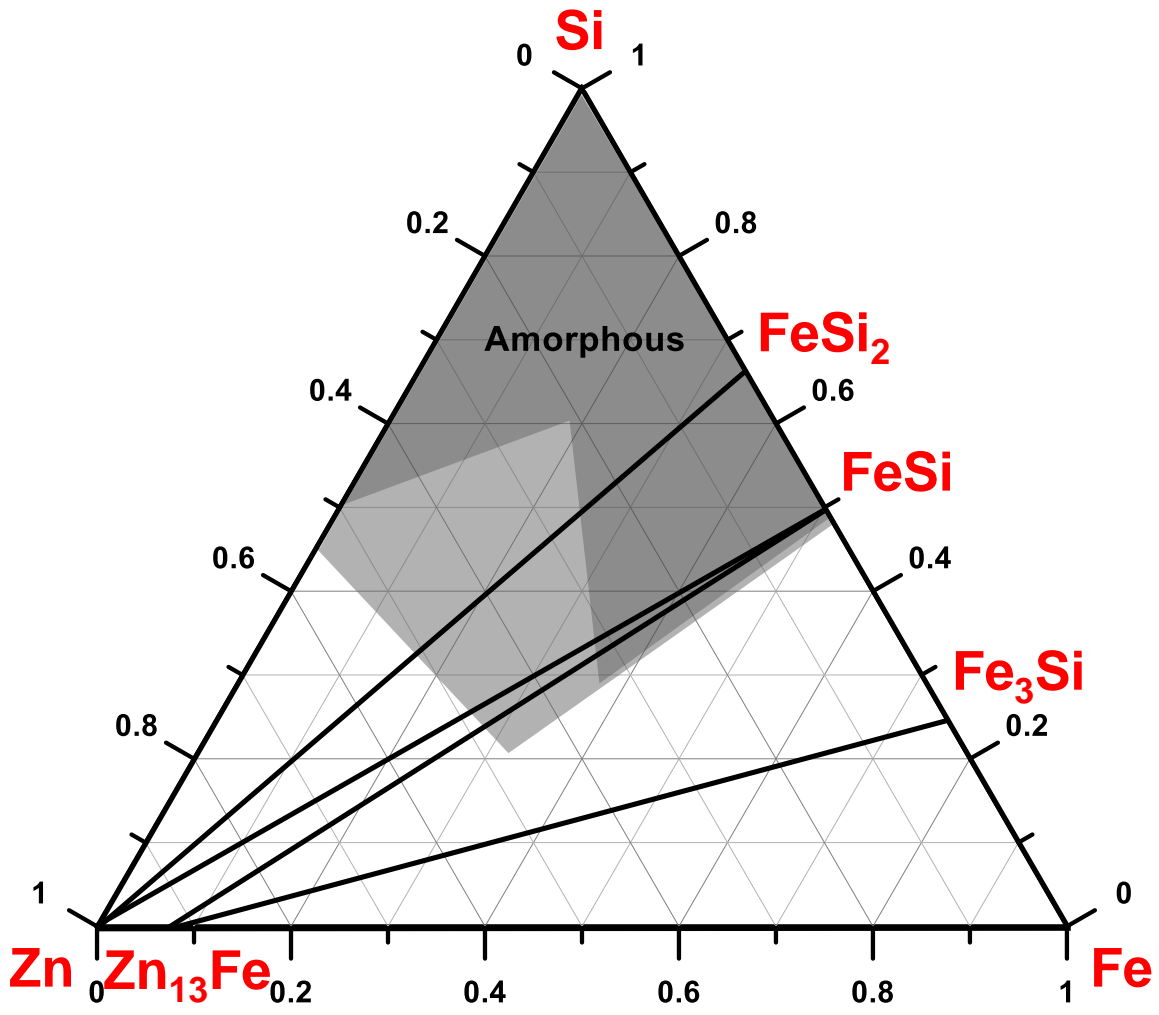
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Figure 3



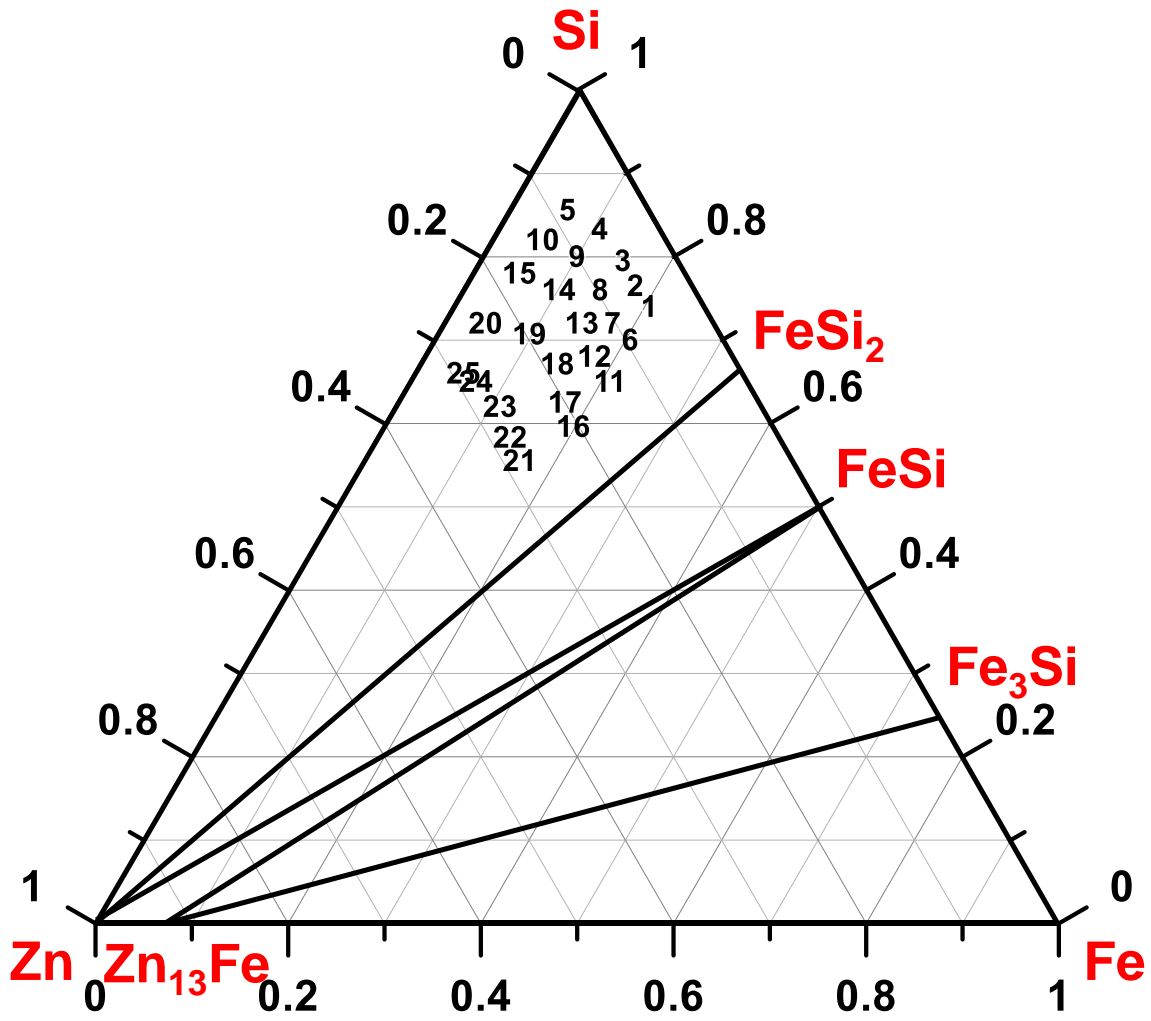
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390 **Figure 4**
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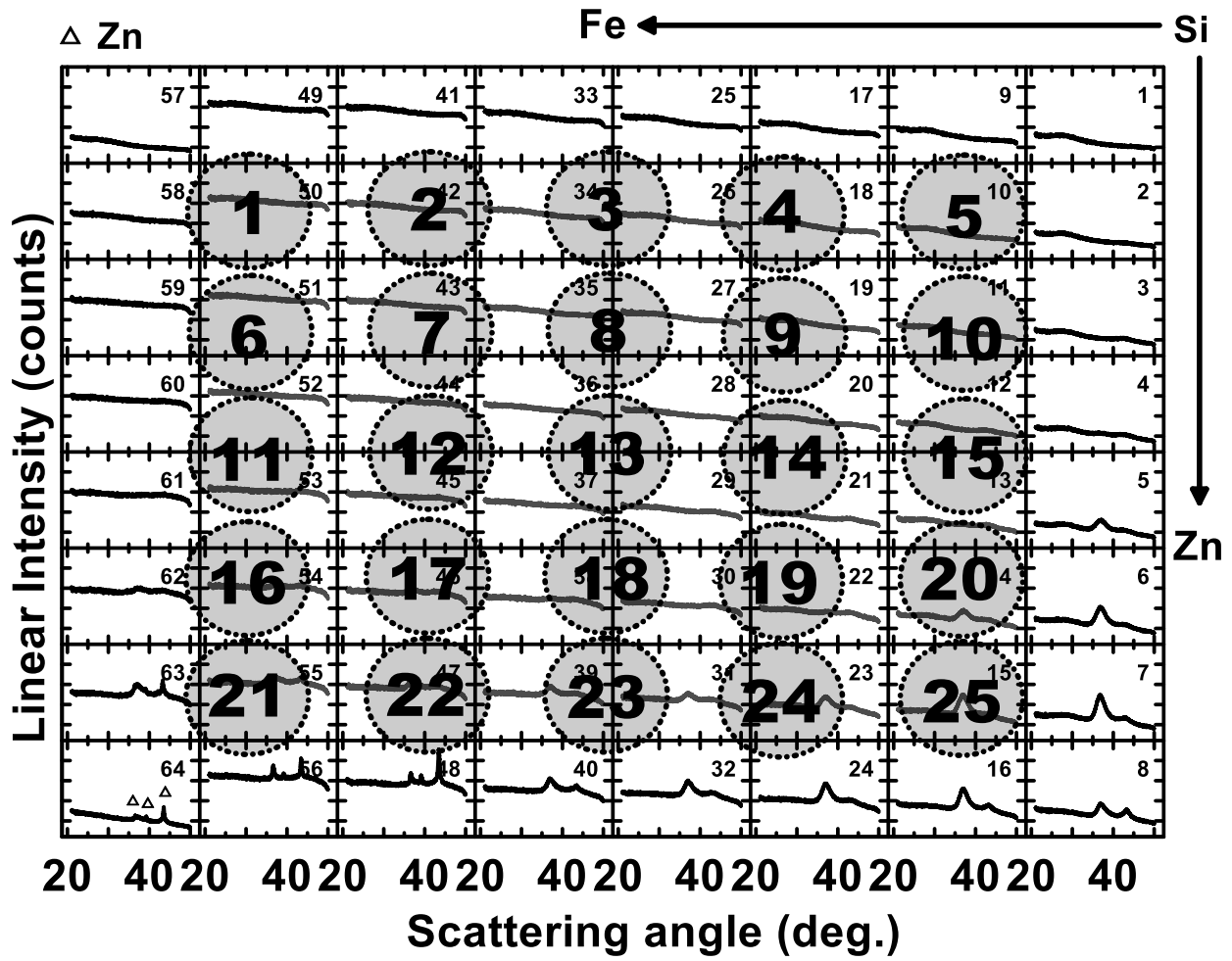
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396 **Figure 5**
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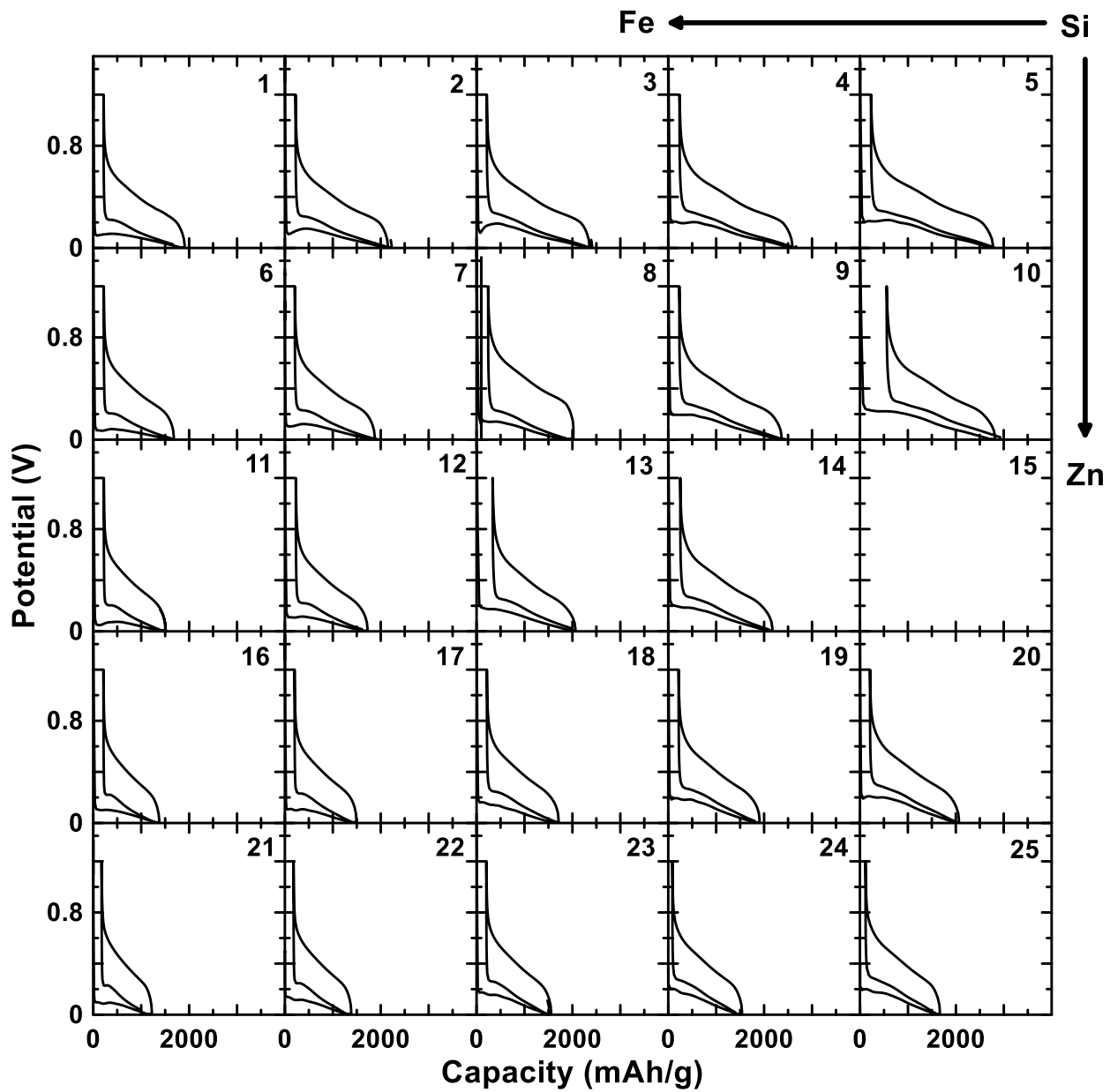
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402 Figure 6
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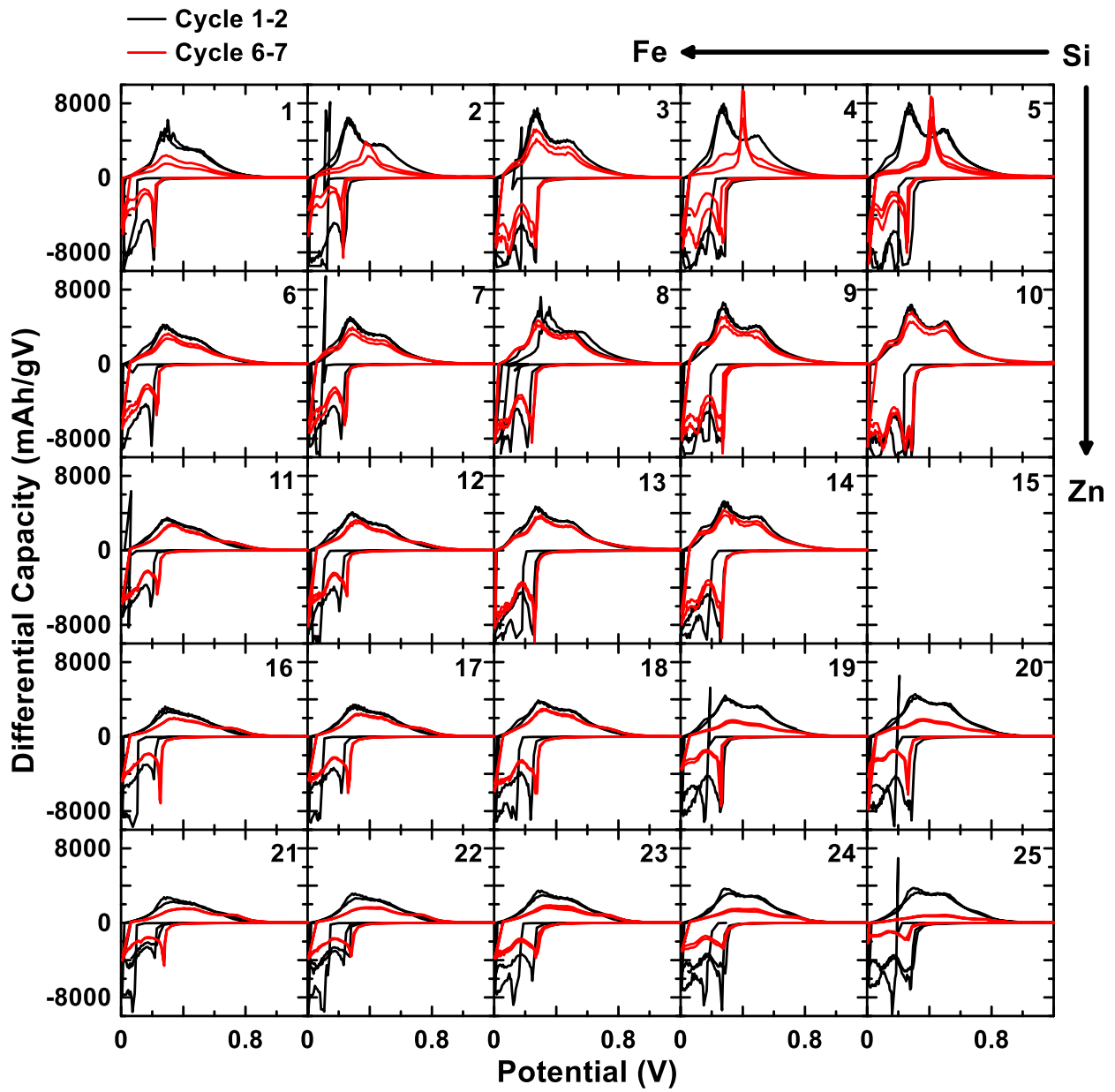
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408 **Figure 7**
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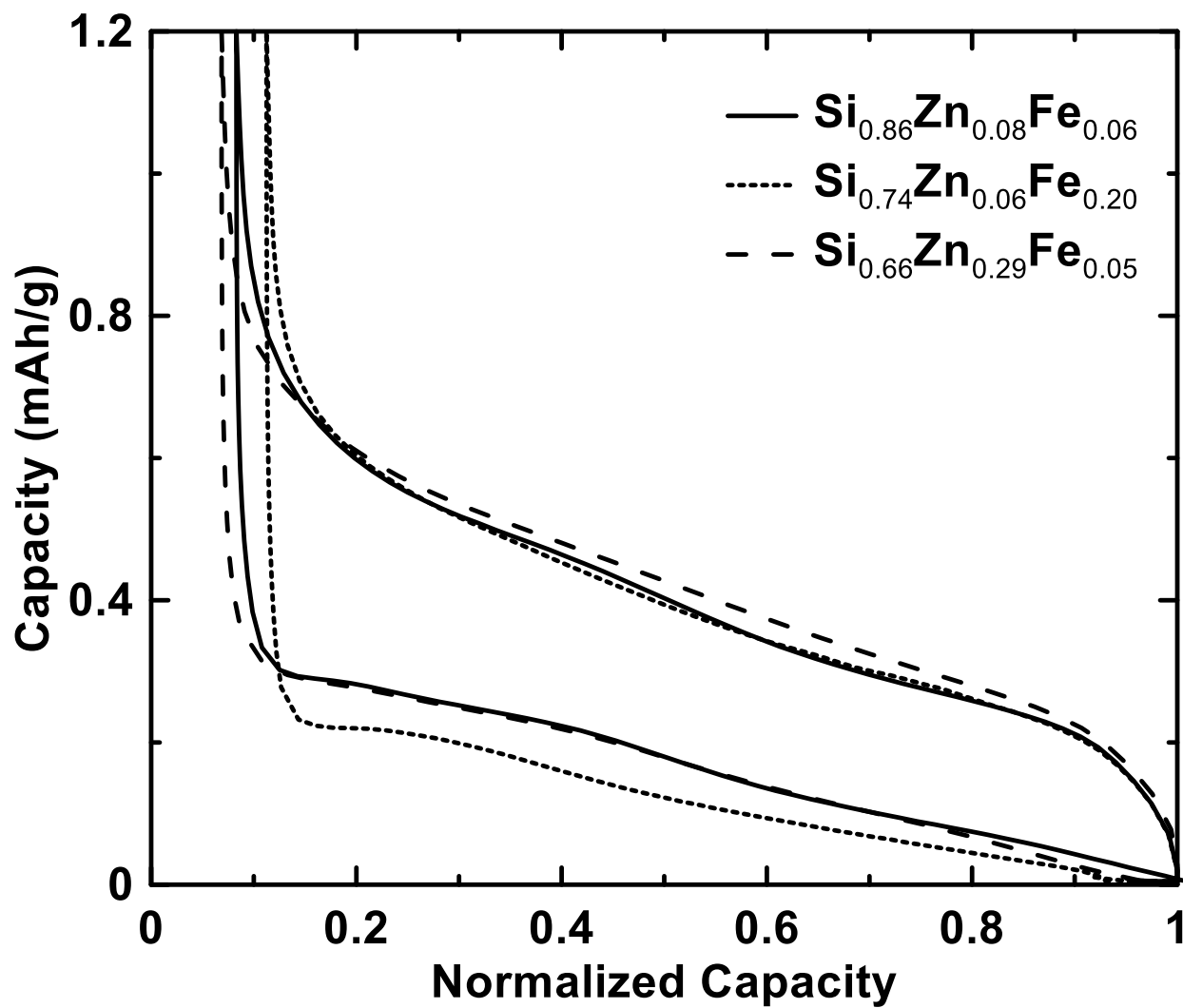
413 **Figure 8**
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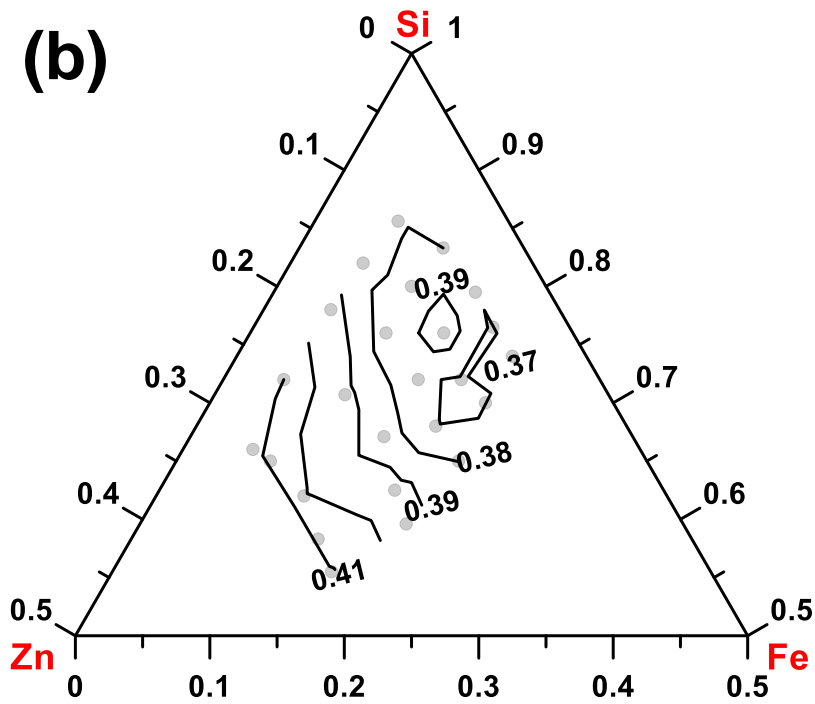
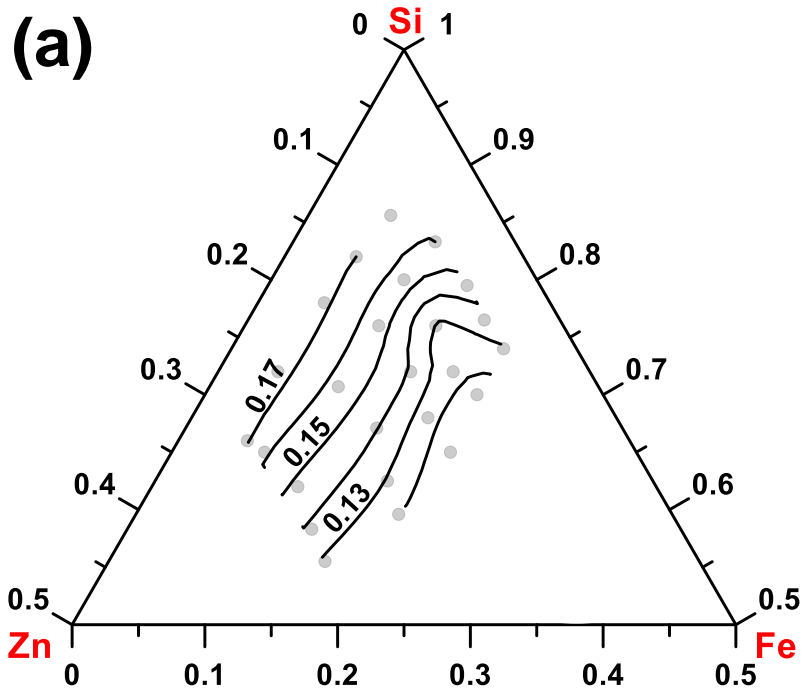
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Figure 9



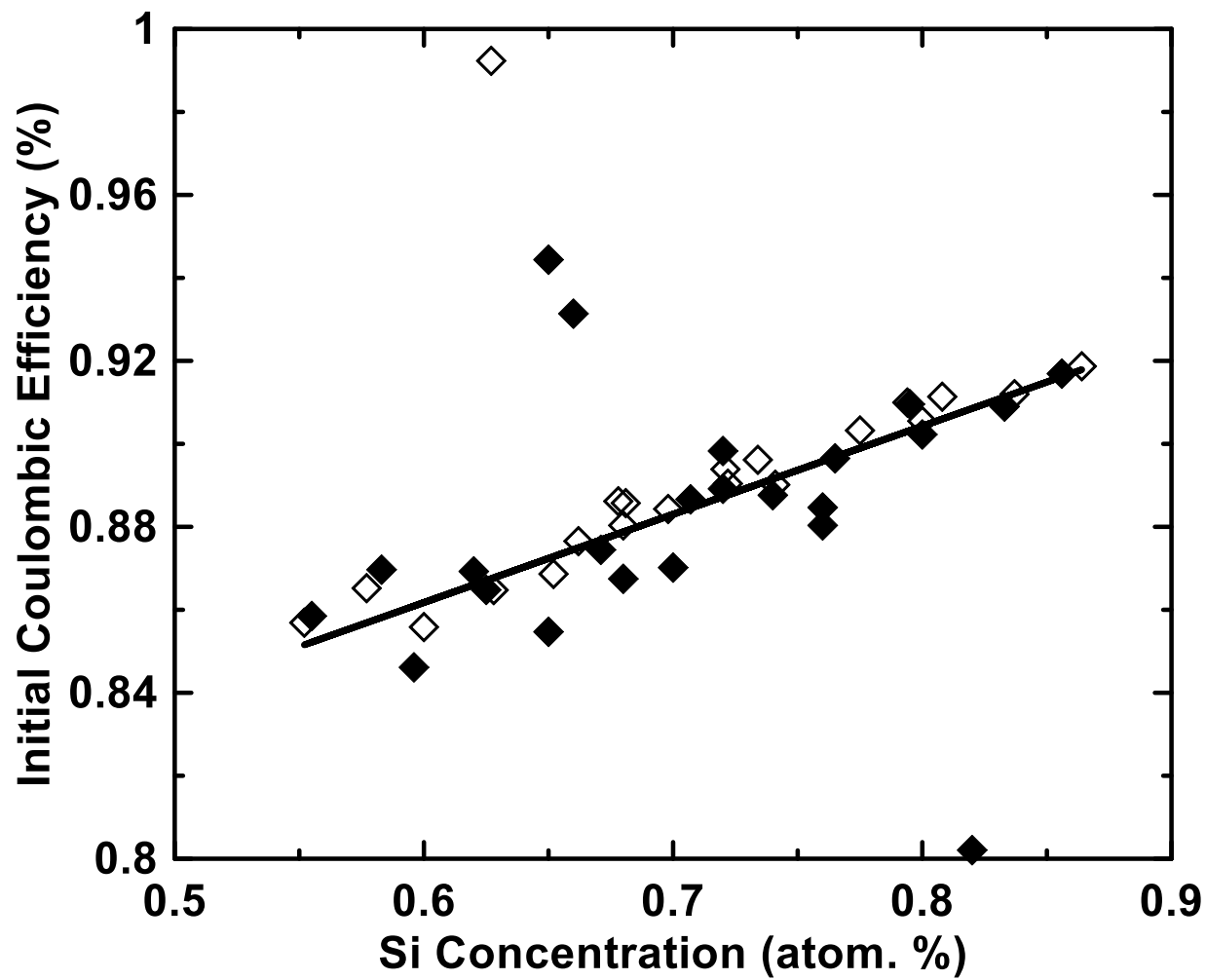
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427 **Figure 10**
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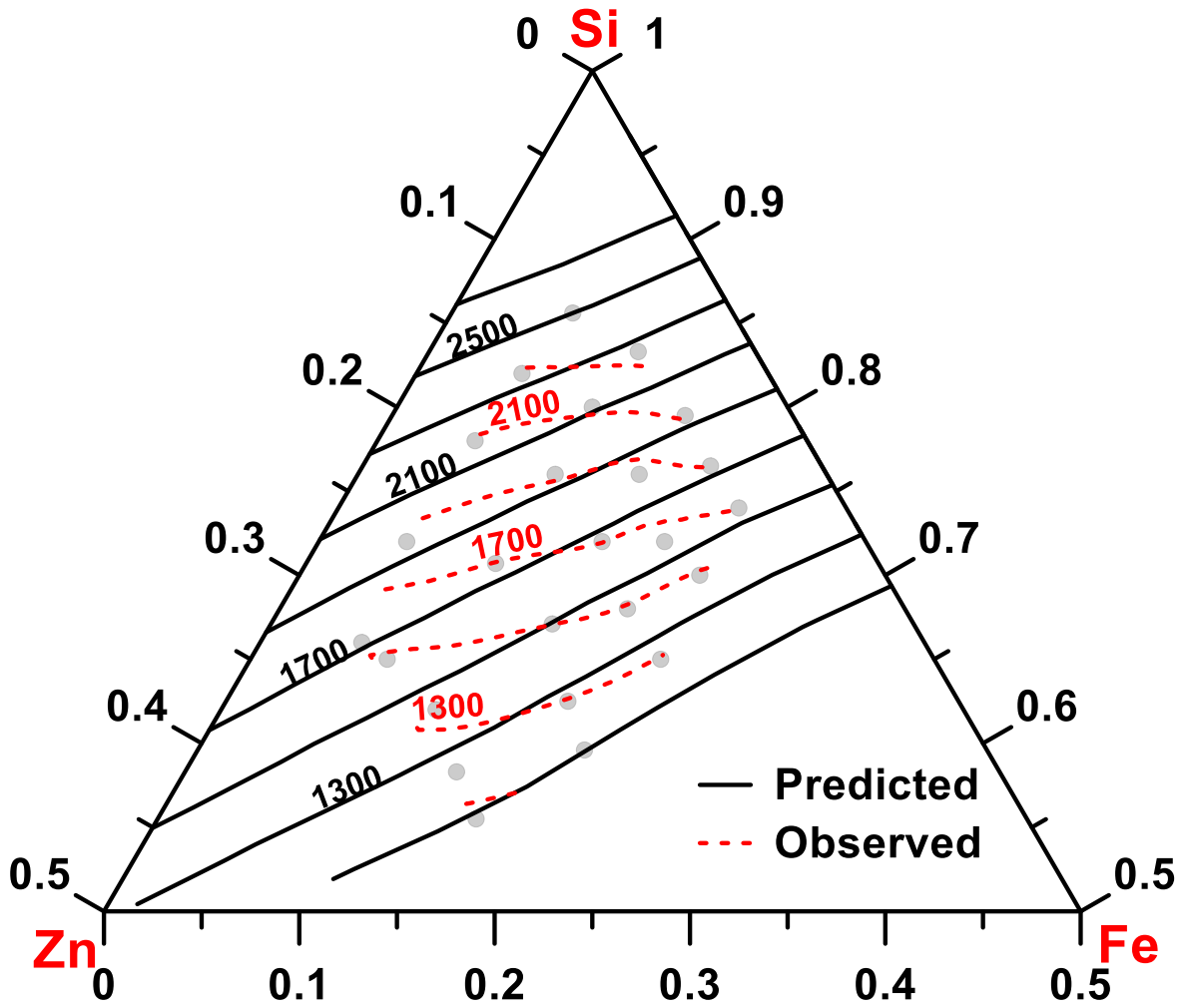
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434 Figure 11
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440 **Figure 12**
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